

# Measurements and Modeling of Liquid Metal Sputtering in IIAX at UIUC

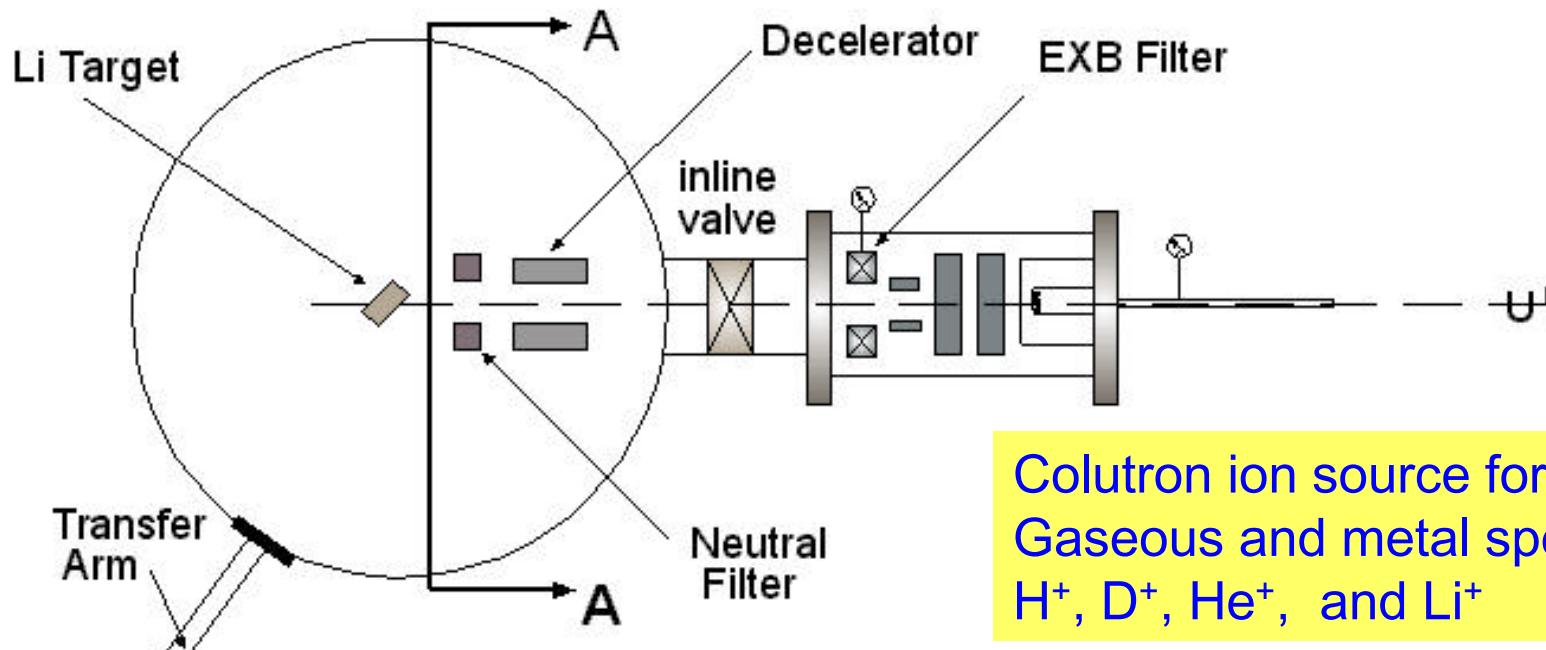
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D.N. Ruzic

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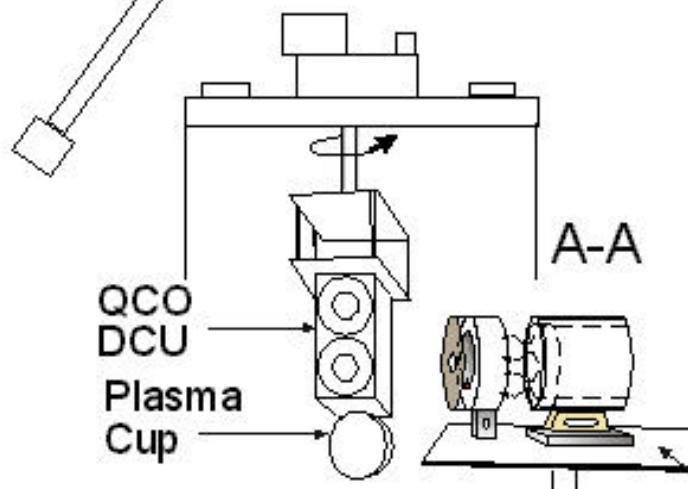
ALPS Electronic Meeting  
May 4, 2001

# Outline of Talk

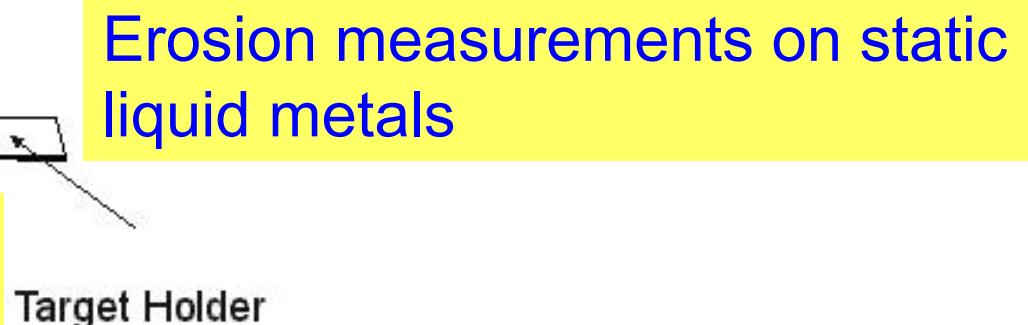
- Experimental setup of IIAX (Ion-surface Interaction Experiment)
- Lithium erosion studies in IIAX.
- Experimental results for liquid lithium and liquid tin lithium
- Temperature dependence of the Li sputtering yield from lithium and tin-lithium surfaces
- Key issues and mechanisms
- Conclusions and Future Work



Colutron ion source for both  
Gaseous and metal species:  
 $H^+$ ,  $D^+$ ,  $He^+$ , and  $Li^+$



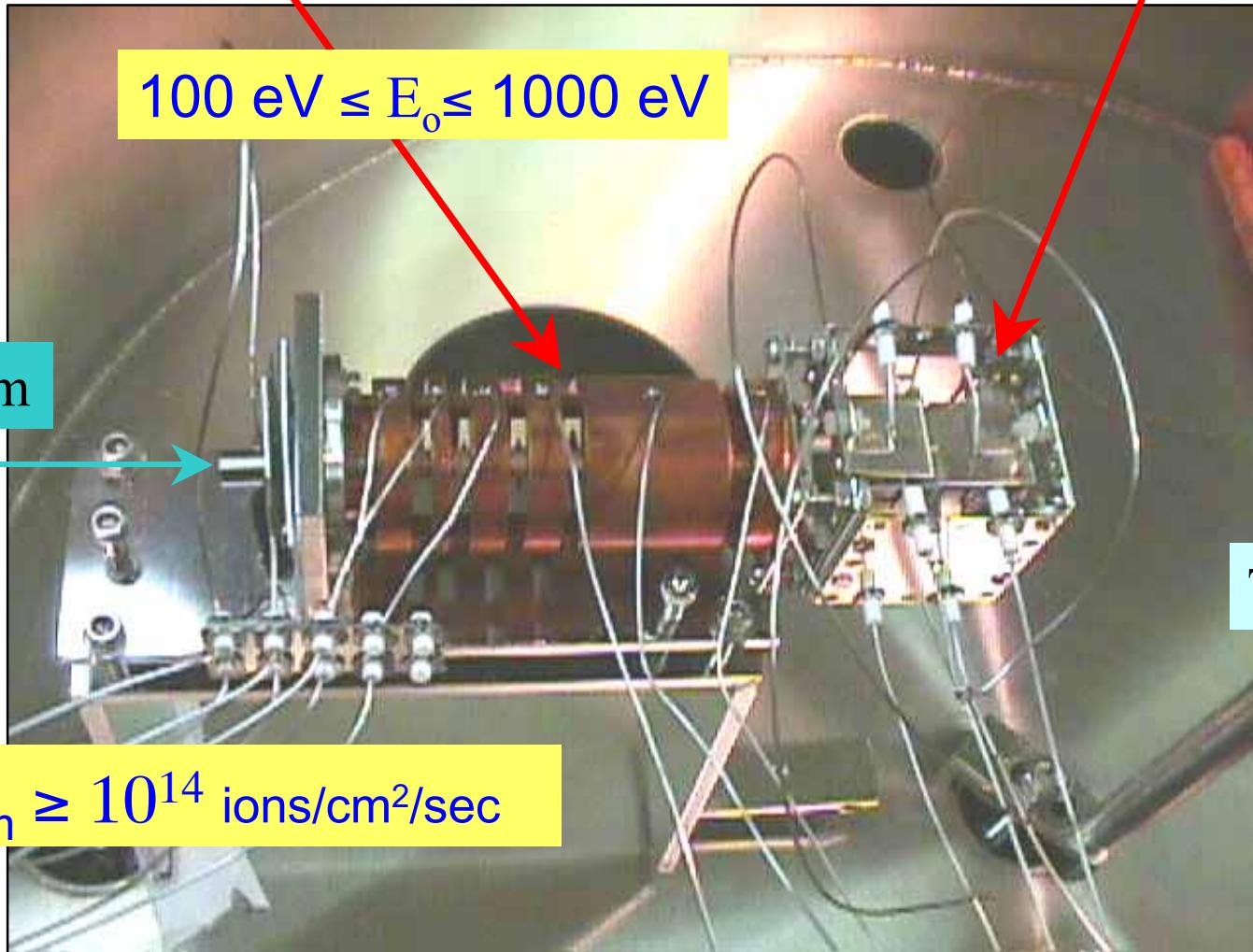
QCO (Quartz crystal oscillator)  
Microbalance dual unit,  $\pm 0.1 \text{ \AA}$ )



$\Gamma_D^+ = 10^{17} \text{ ions/cm}^2/\text{sec}$ , flux from  
hollow cathode source

Target Holder

# Decelerator and Neutral Filter

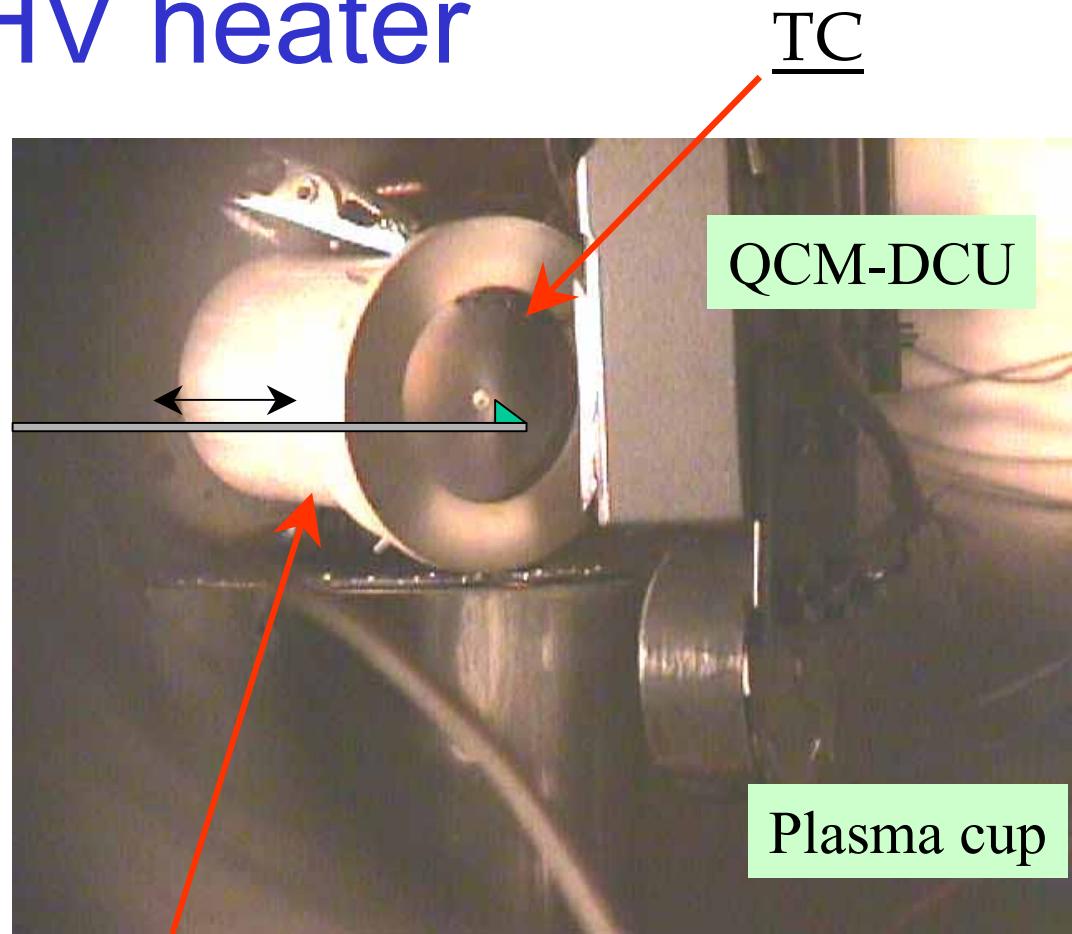


# Evaporation Shield for Liquid Metal Sputtering Measurements

- Evaporation rate for Li at 200 °C:
  - calculated:  $4 \times 10^{11} / \text{cm}^2/\text{sec}$
  - measured:  $5.1 \times 10^{11} / \text{cm}^2/\text{sec}$
- Evaporation rate for 0.8 Sn-Li at 380 °C:
  - calculated:  $5 \times 10^{12} / \text{cm}^2/\text{sec}$
  - measured:  $2 \times 10^{12} / \text{cm}^2/\text{sec}$
- Sputtering rate for 50 nA beam, Y=0.1, on a spot size of 0.32 mm by 0.32 mm:  $8 \times 10^{13} / \text{cm}^2/\text{sec}$
- To eliminate evaporation from regions not being struck by the ion beam, a thin tantalum metal sheet with a small hole is floated on top of the liquid Li or liquid 0.8 Sn-Li surface as an evaporation shield.

# In-situ cleaving arm design and HV heater

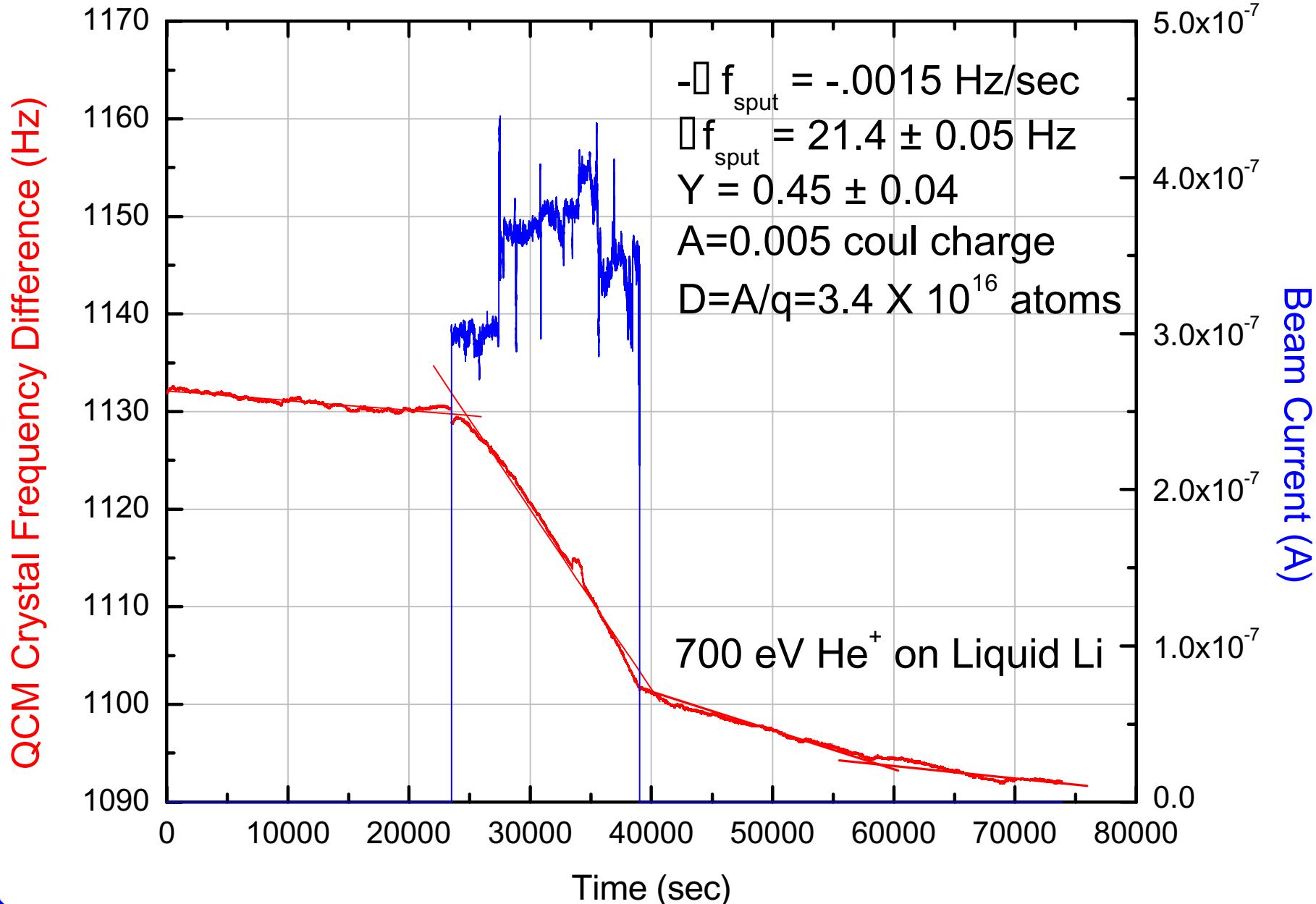
- Cleaving arm is designed to remove thin oxide layer formed on Li layer of liquid tin-lithium or liquid lithium sample
- Surface composition experiments show that Li segregates to the liquid Sn-Li surface<sup>1</sup>



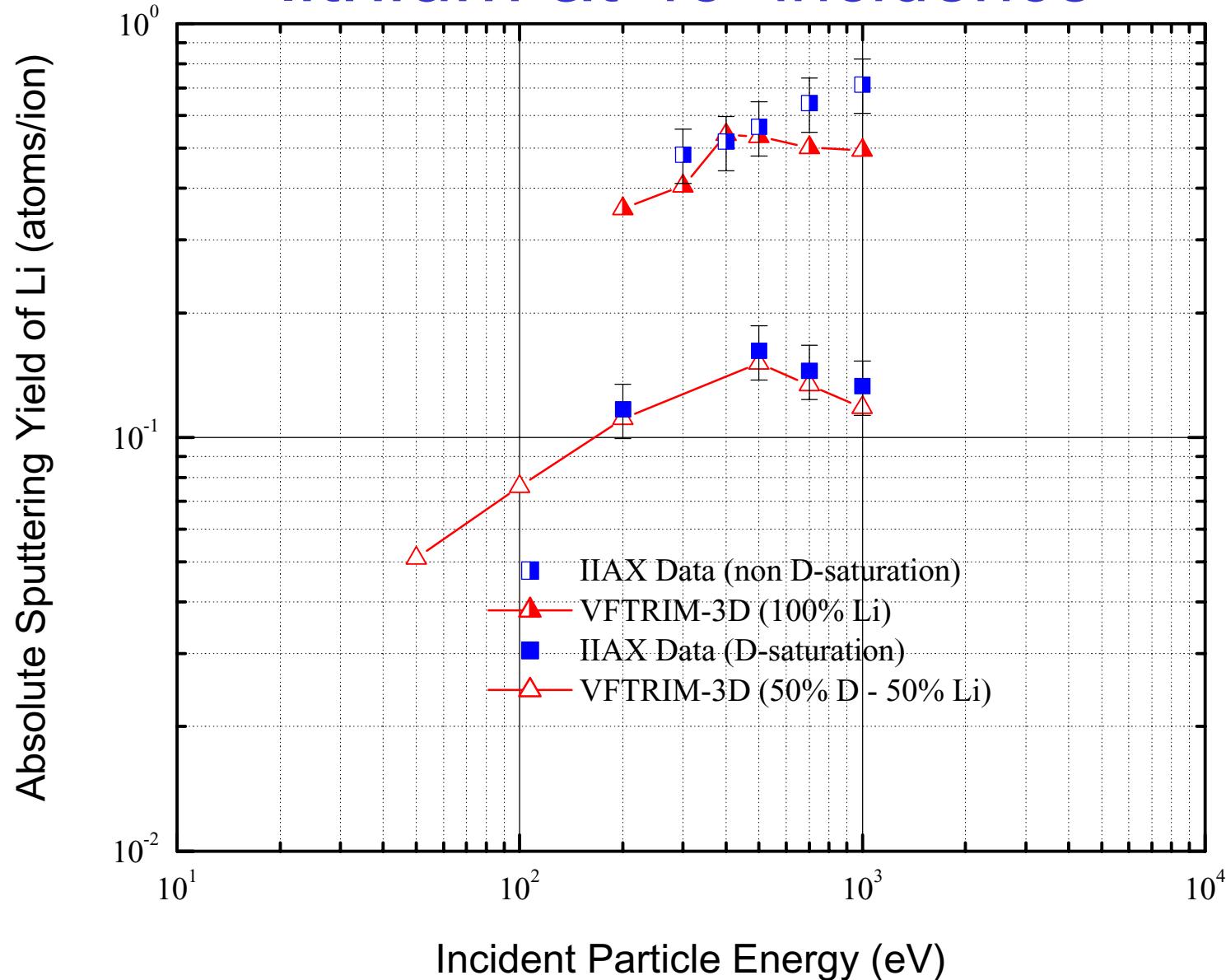
A HV heater was installed inside a BN cup.

1. R. Bastasz and W. Eckstein, J. Nucl. Mater. 290-293 (2001) 19-24

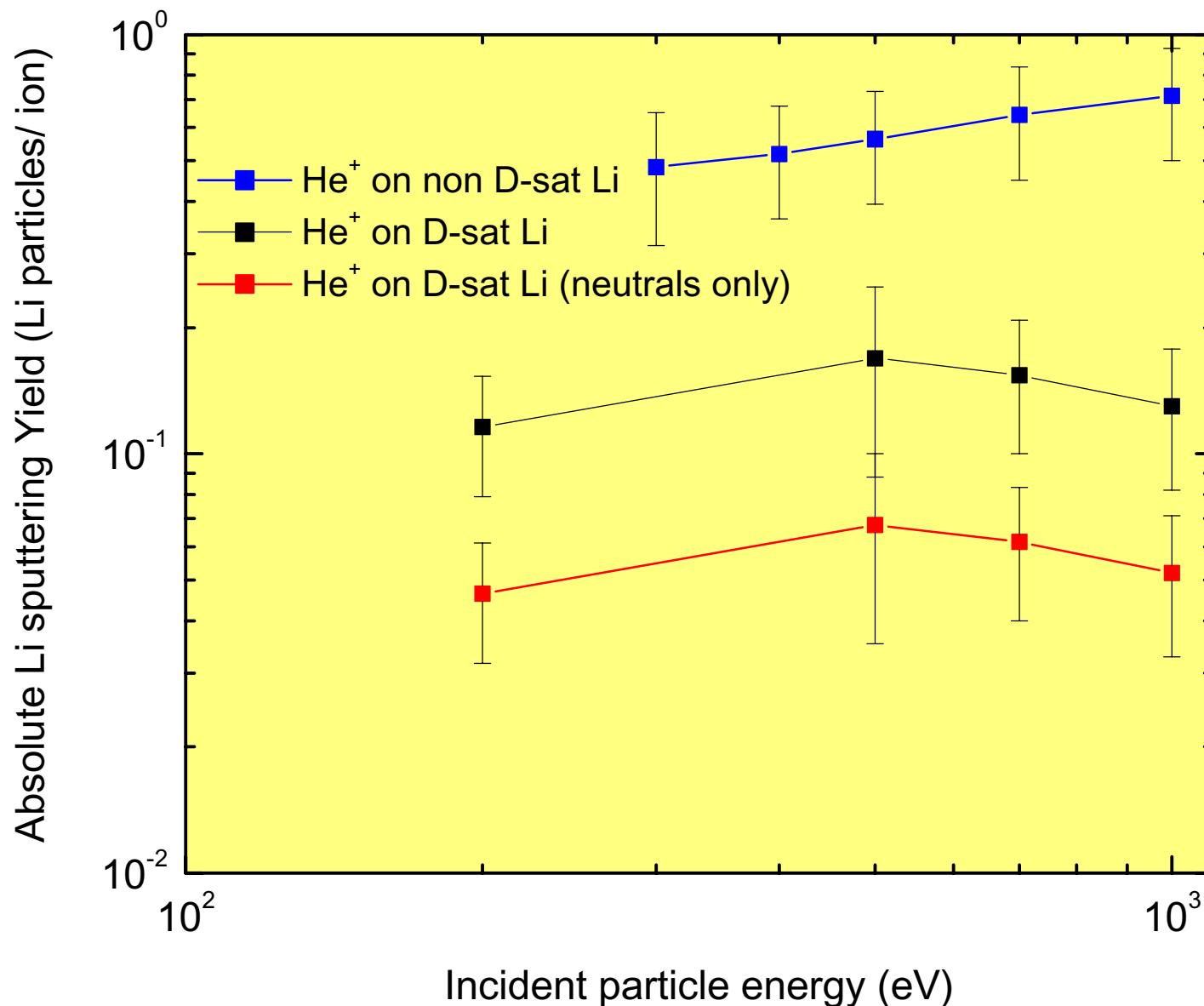
## QCM Frequency Difference and Beam Current vs. Time



# $\text{He}^+$ on D-saturated and non D-sat. lithium at $45^\circ$ incidence

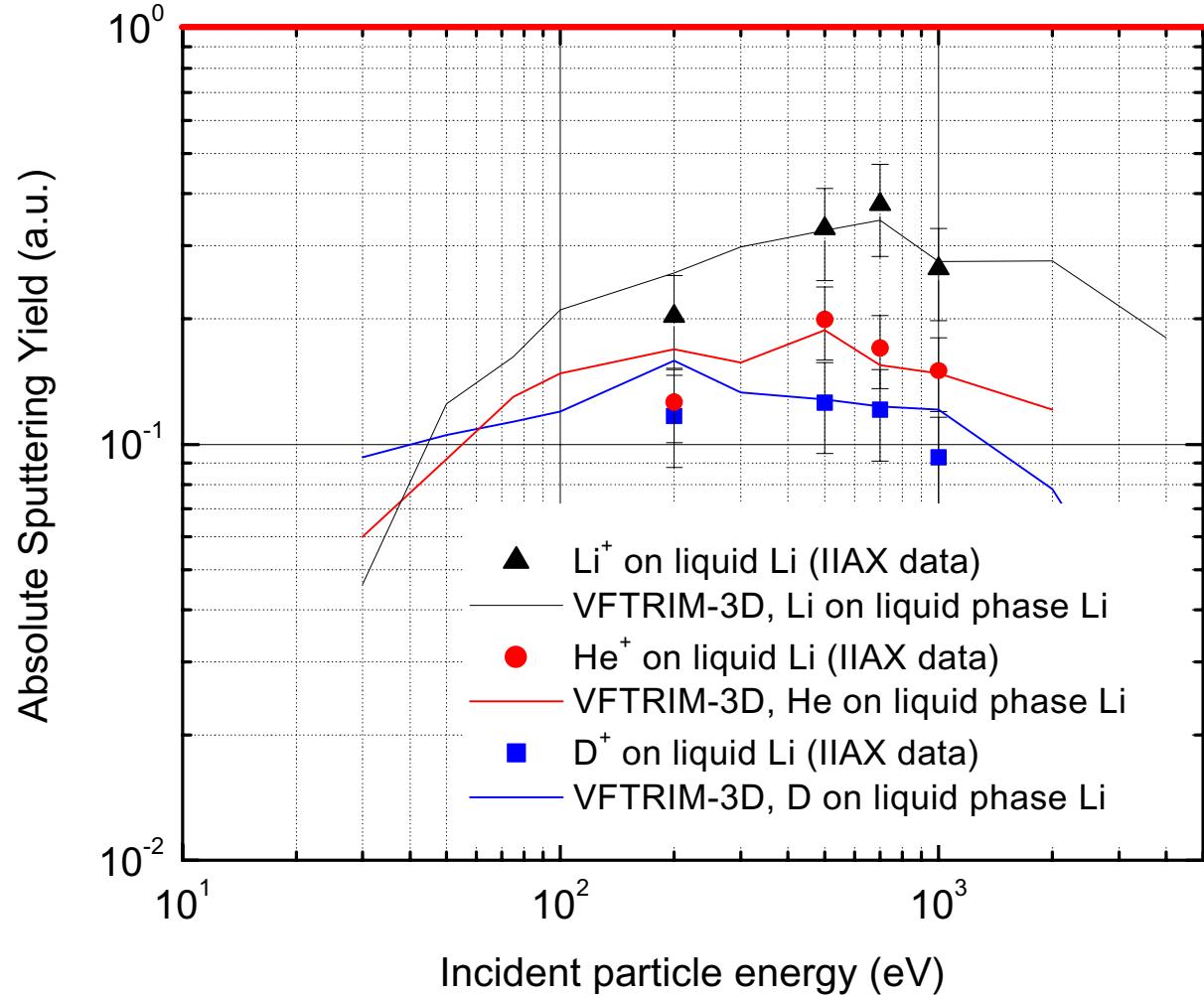


# D-treatment effect on lithium sputtering



# IIAX experimental and modeling data on liquid lithium erosion

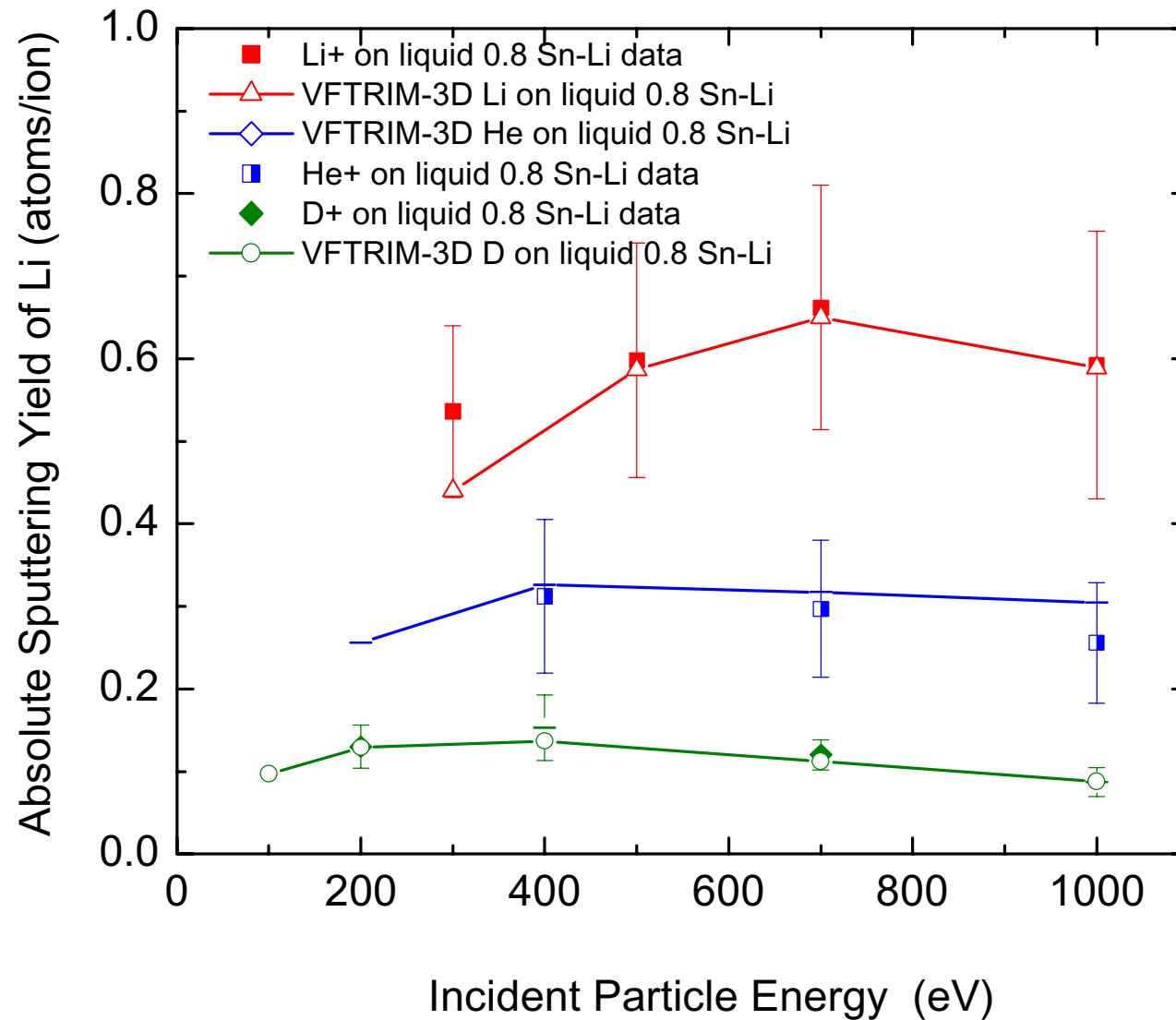
- D-treated lithium yields are well below unity
- Data taken at 45 deg. Incidence and 200 °C surface temperature



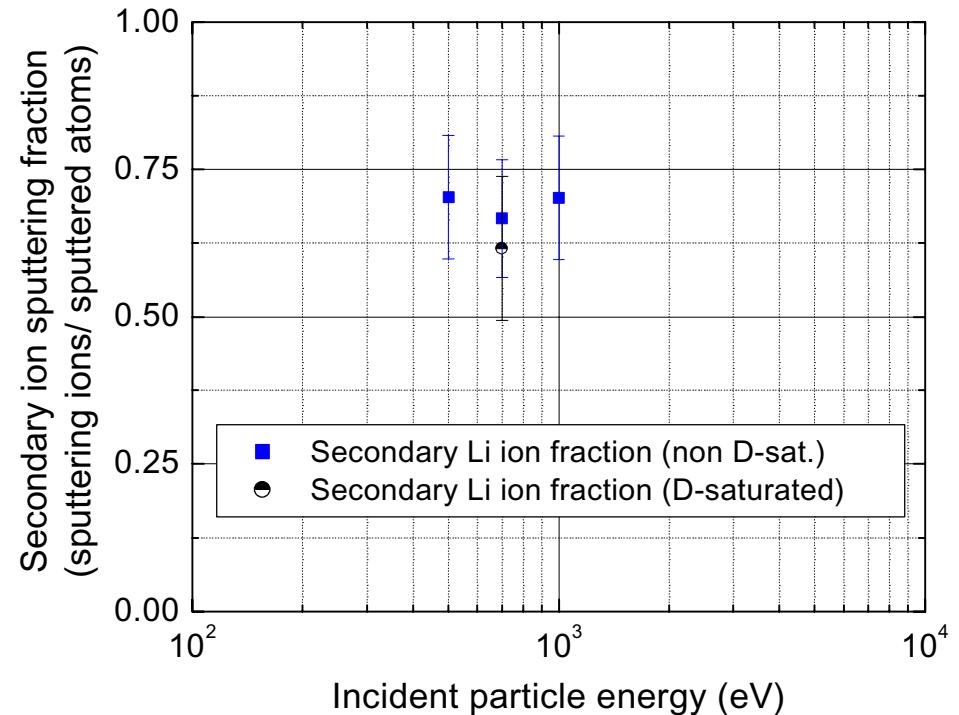
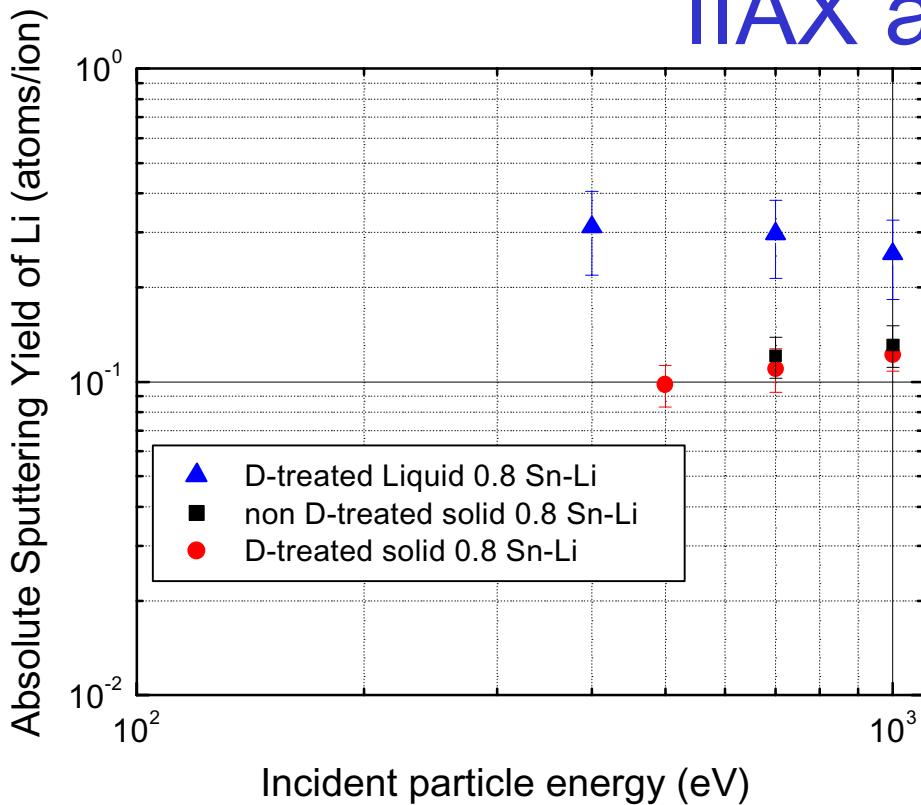
J.P. Allain, M.R. Hendricks and D.N. Ruzic, J. Nucl. Mater. 290-293 (2001) 180

# $D^+$ , $He^+$ and $Li^+$ bombardment of liquid tin-lithium data and VFTRIM-3D simulation at 45-degree incidence.

( J.P. Allain, M.R. Hendricks, D.N. Ruzic, J.Nucl.Mater. 290-293 (2001) 33-37)

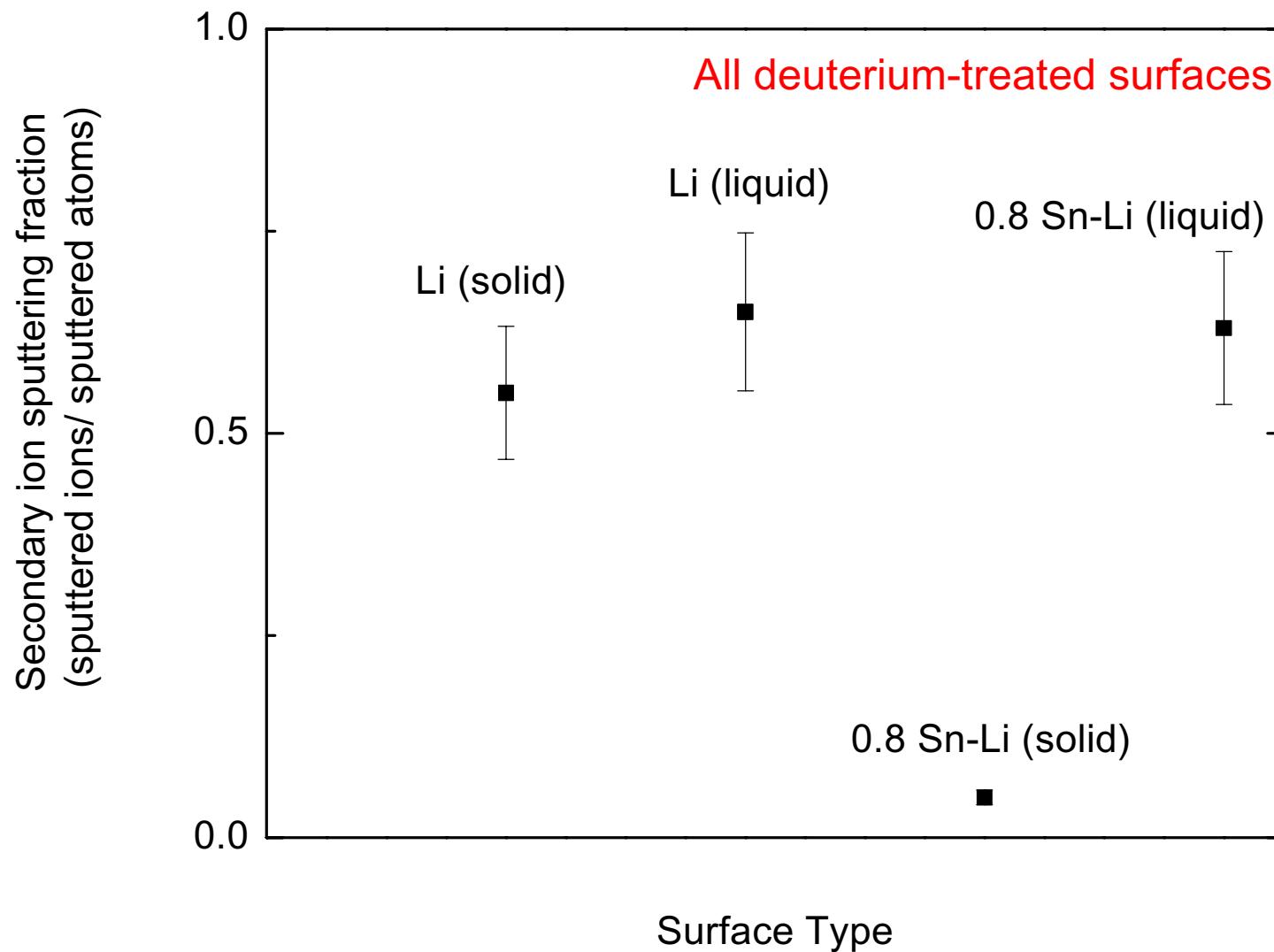


# Secondary ion fraction and deuterium-saturation studies of liquid metals in IIAX at UIUC

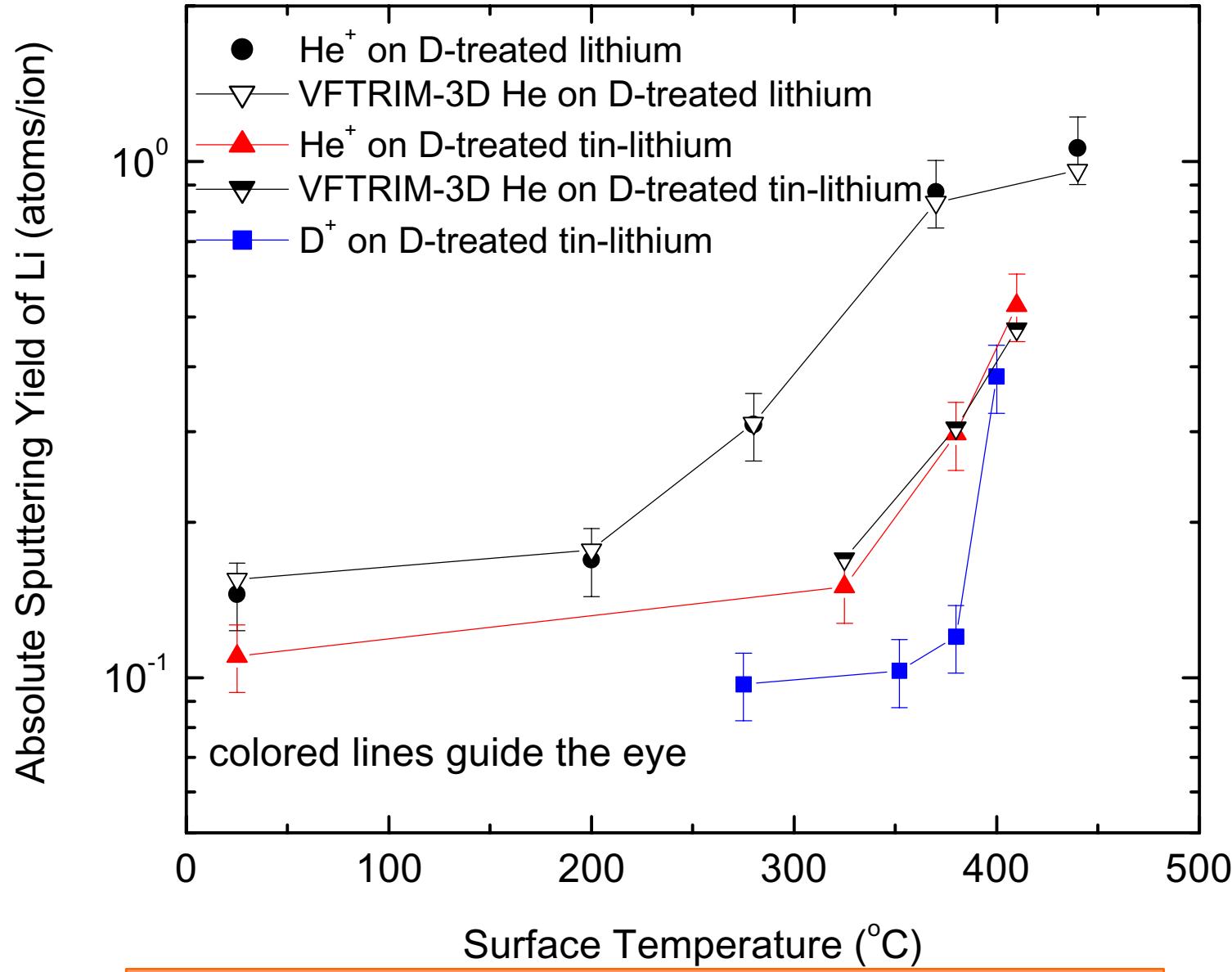


- Saturation of solid and liquid ( $T/T_m \sim 1$ ) tin-lithium with D atoms results in no effect on the absolute sputtering yield of lithium.
- Ion fraction measurements show that 55-65% of sputtered atoms from D-saturated solid and liquid lithium are in an ionized state.

# Secondary Ion Fraction of sputtered Li as a function of surface



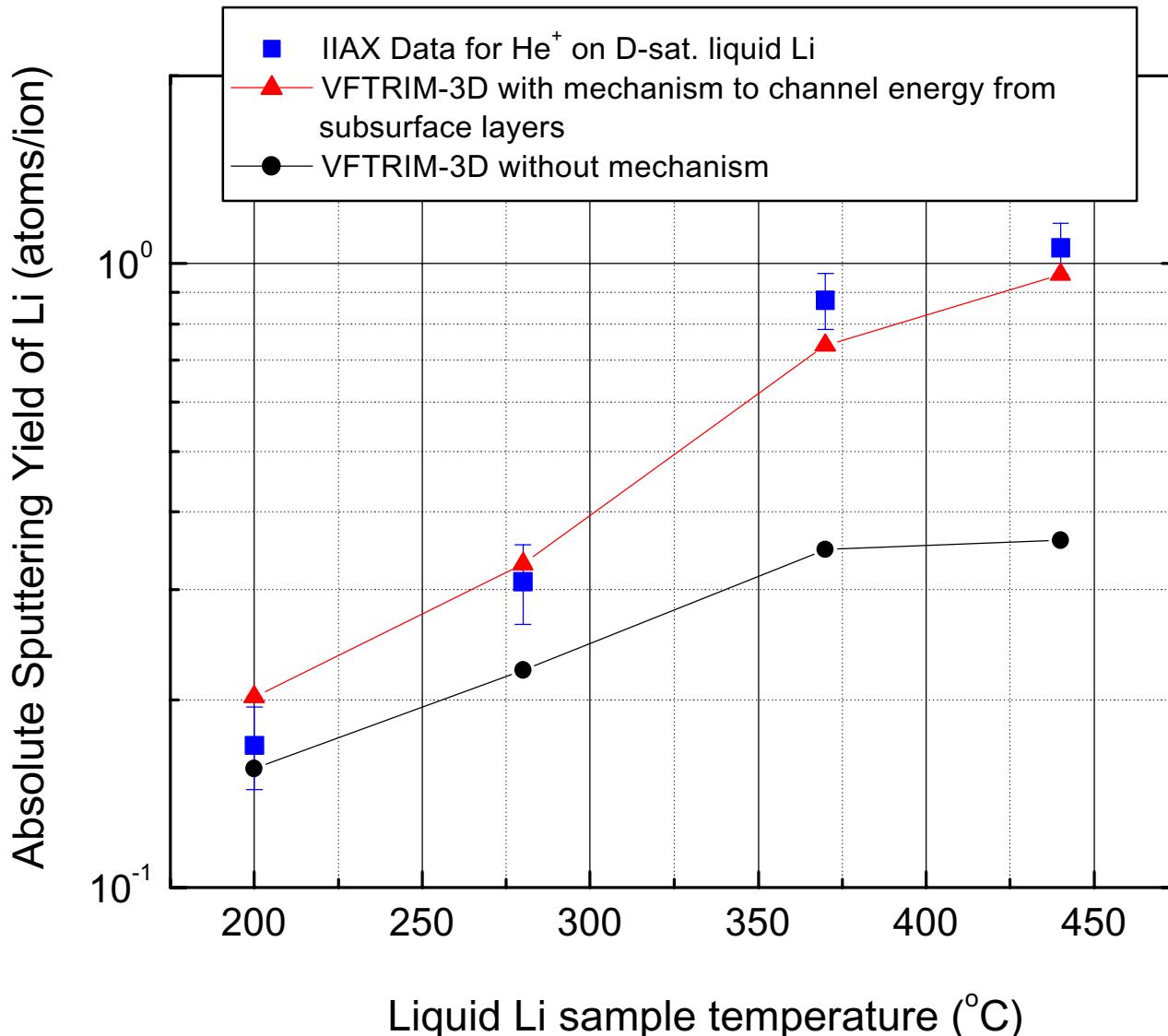
# Lithium sputtering yield temperature dependence for lithium and tin-lithium targets



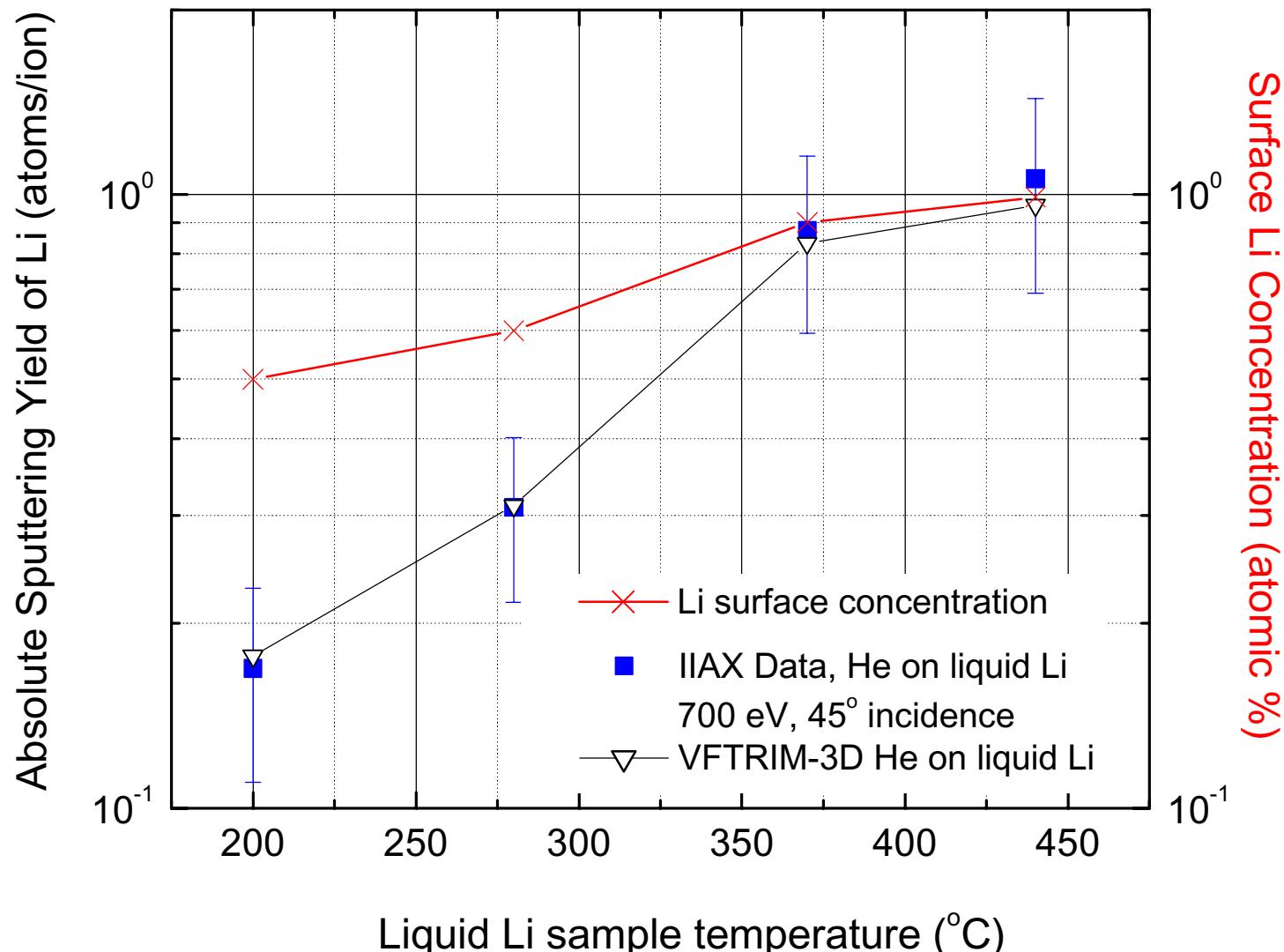
# VFTRIM-3D Model for temperature dependence in IIAX liquid lithium sputtering data

- Initially began with surface model for D-treated liquid lithium (presented earlier) at 200 C.
- Deuterium surface concentration varied as  $T/T_m$  increases with mechanism for channeling energy from subsurface layers to the top surface layer.
- Surface binding energy calibrated to mean ejected energy of sputtered lithium atoms measured in PISCES-B. Assuming Thompson distribution with  $sbe \sim \langle E_{sp} \rangle / 2$ .  
**(R.P. Doerner, et al. J. Nucl. Mater. 290-293 (2001) 166-172.)**
- Density of liquid lithium layer calibrated to experimental data of temperature dependent density (~ weak T function)  
**(T. Iida and R.I.L. Guthrie, “The Physical Properties of Liquid Metals”, Oxford, 1988)**

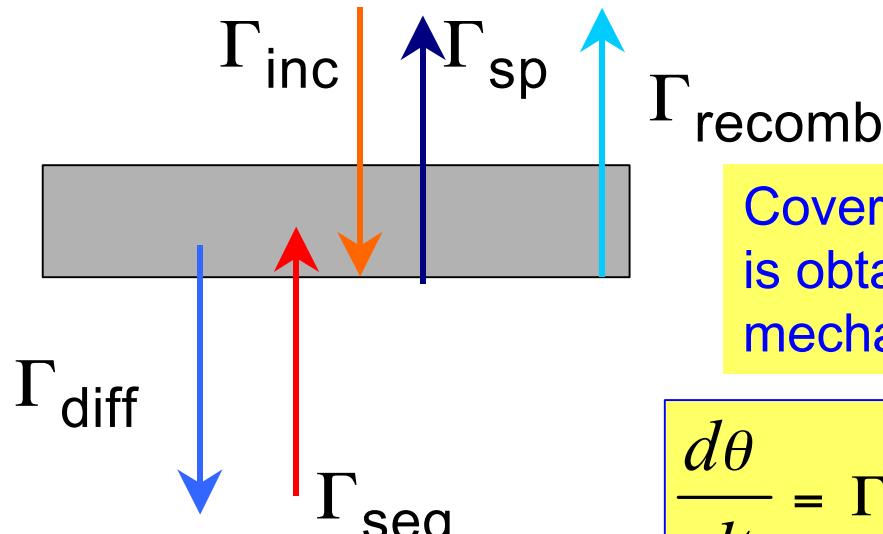
# VFTRIM-3D Simulation for $\text{He}^+$ on D-sat. liquid Li as a function of target temperature with IIAX data



# Lithium surface concentration of D-treated liquid lithium surfaces as a function of surface temperature



# Model to determine deuterium surface concentration as a function of time for a particular temperature



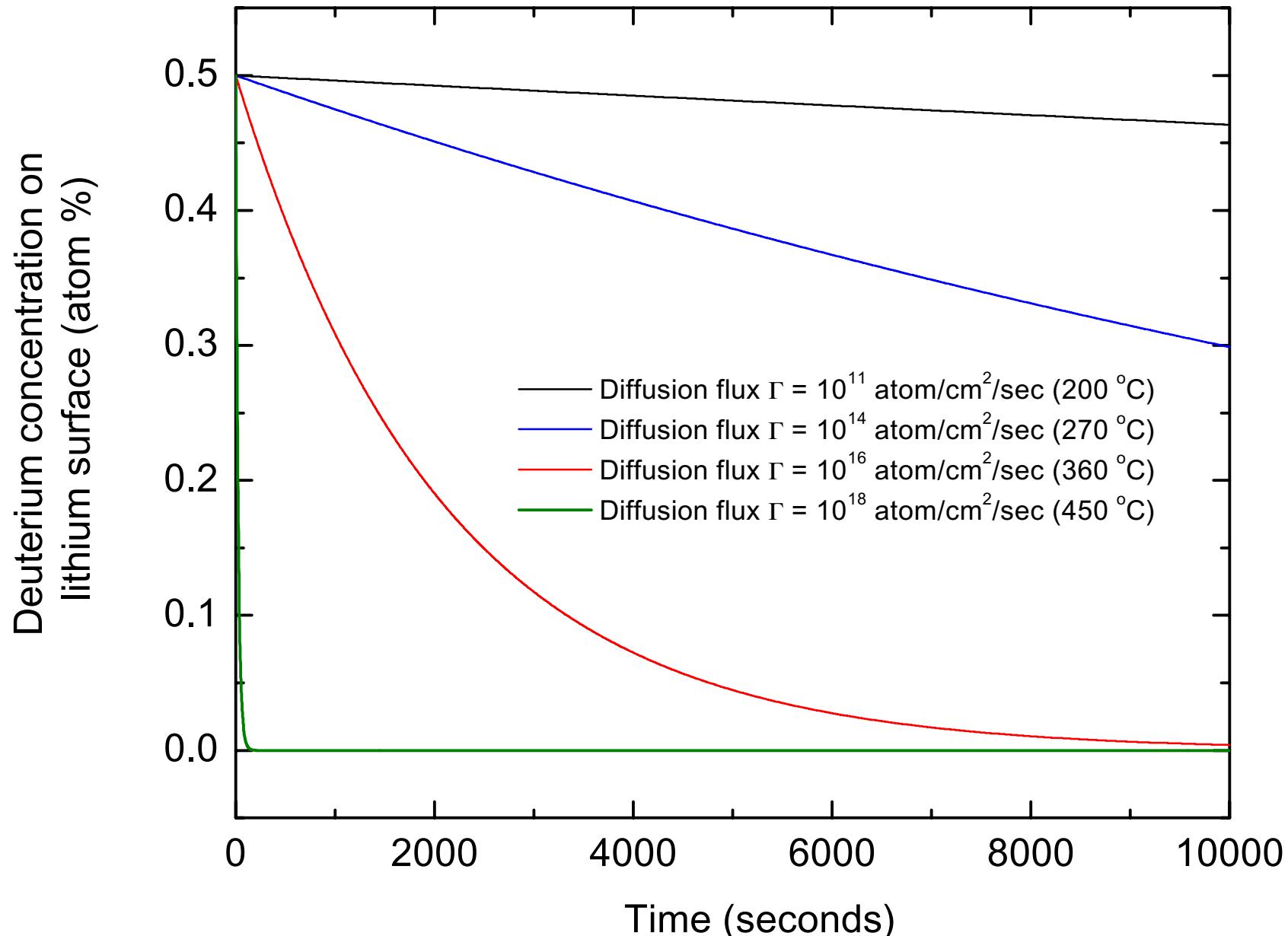
Coverage of deuterium atoms on liquid lithium is obtained accounting for all gain and loss mechanisms

$$\frac{d\theta}{dt} = \Gamma_{\text{imp}} + \Gamma_{\text{seg}} - \Gamma_{\text{sp}} - \Gamma_{\text{diff}} - \Gamma_{\text{recomb}}$$

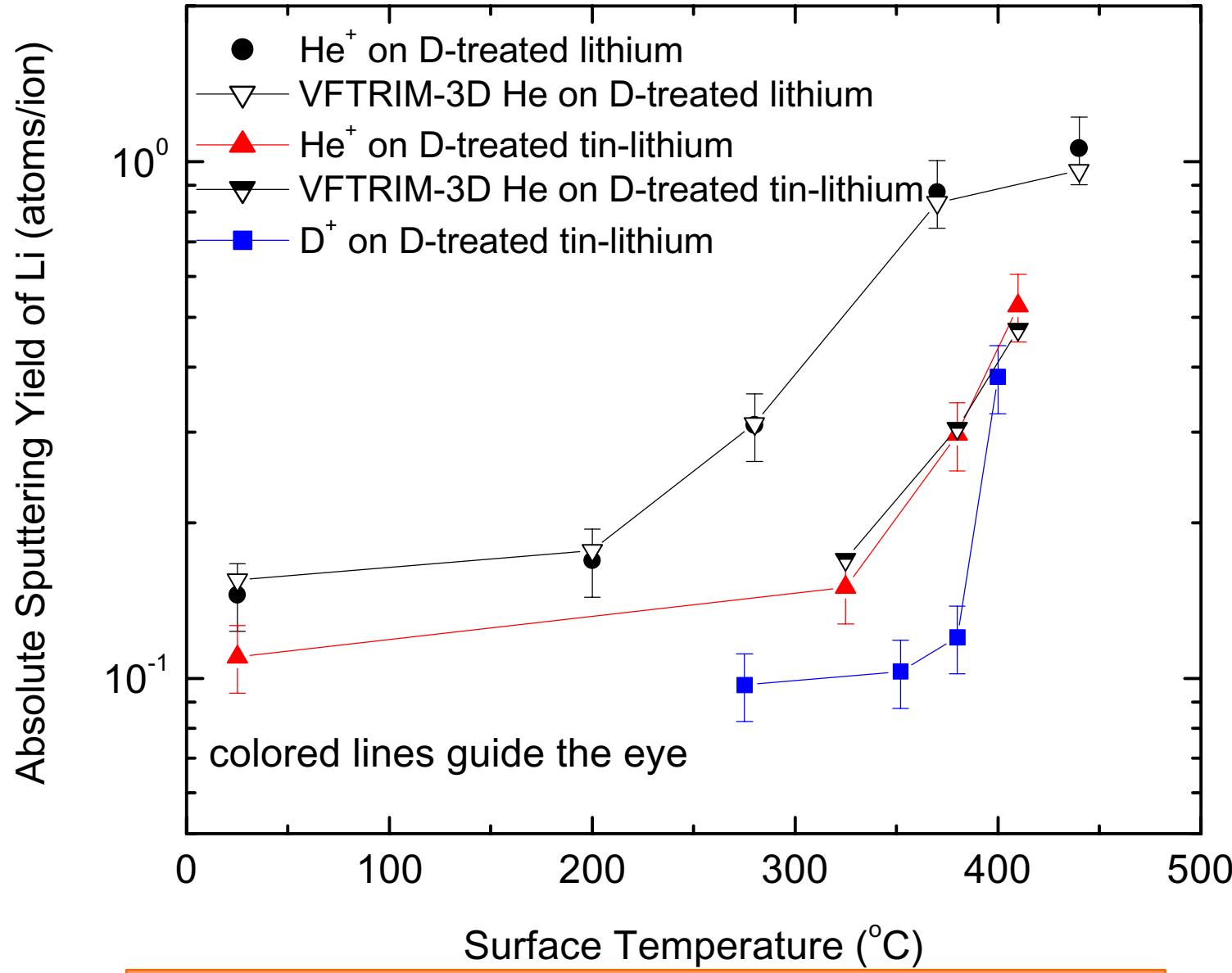
$$\theta(t) = \frac{e^{-k_1 t} (k_2 \sqrt{k_1} + k_3 \text{Erf}(\sqrt{k_1} t))}{\sqrt{k_1}}$$

R. Bastasz and W. Eckstein, J. Nucl. Mater. 290-293 (2001) 19-24  
R. Kirchheim and S. Hoffmann, Surf. Sci. 83 (1979) 296-300

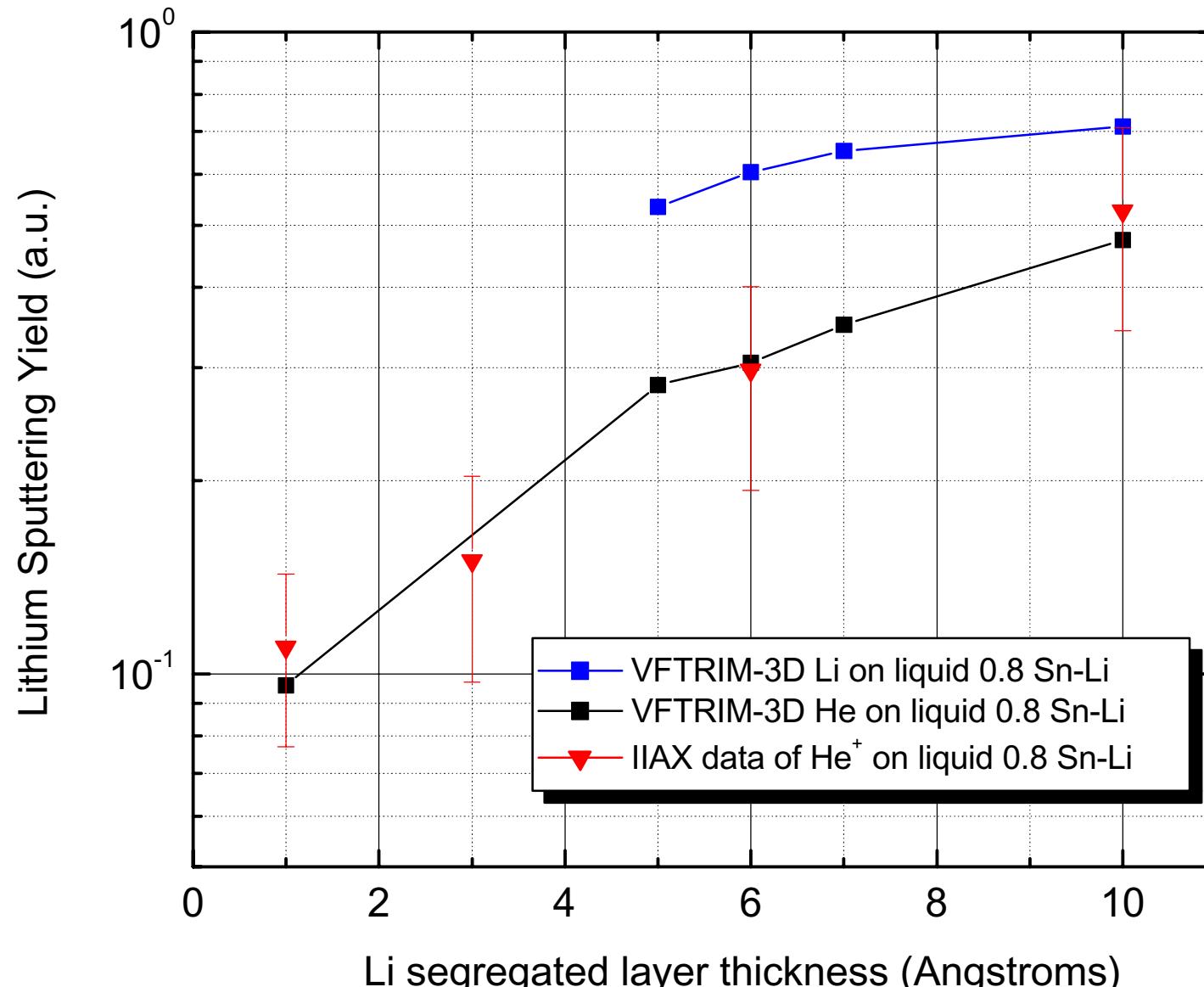
# Kirchheim-Hoffmann Surface Model



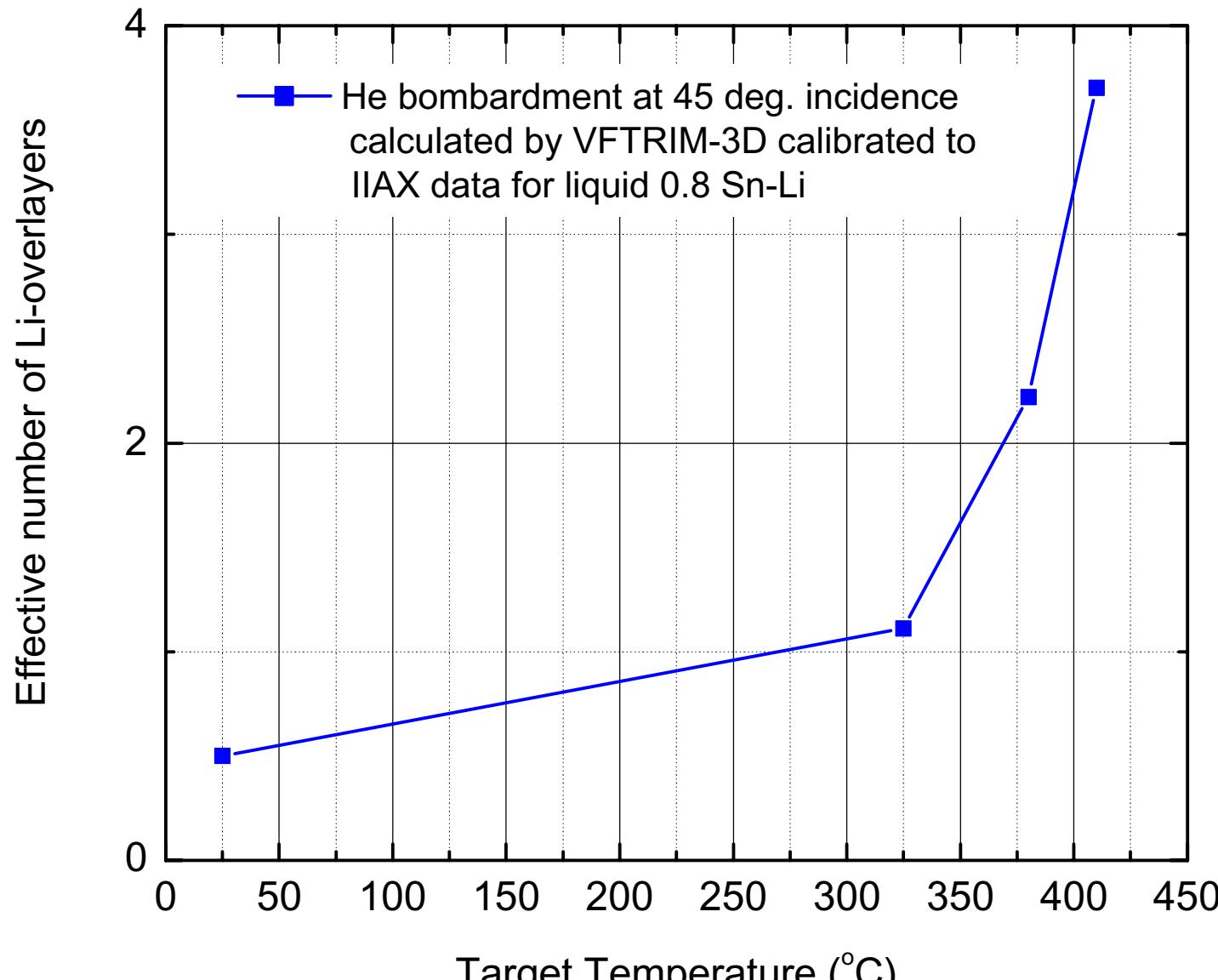
# Lithium sputtering yield temperature dependence for lithium and tin-lithium targets



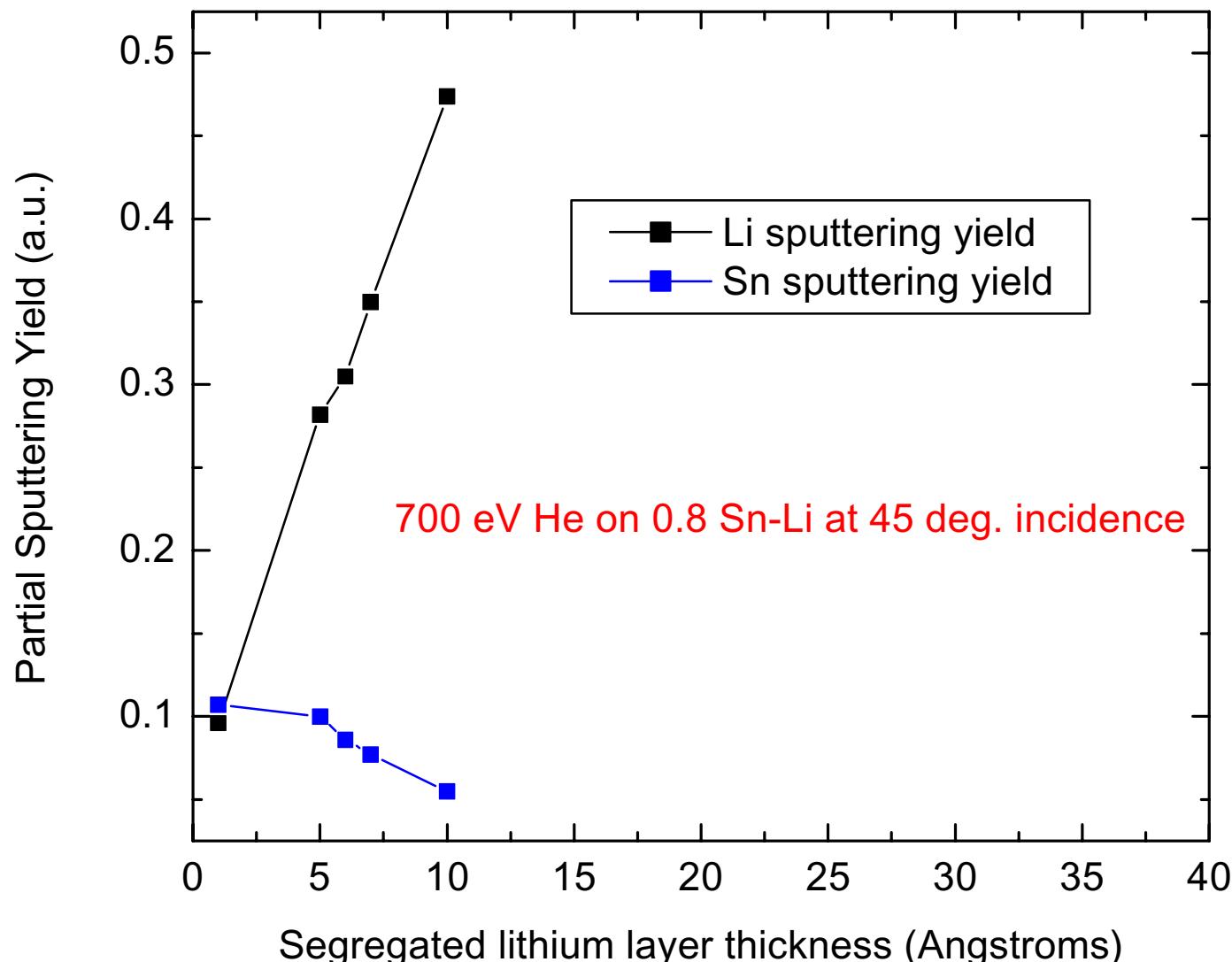
# Partial lithium sputtering yield vs segregated lithium layer thickness in 0.8 Sn-Li



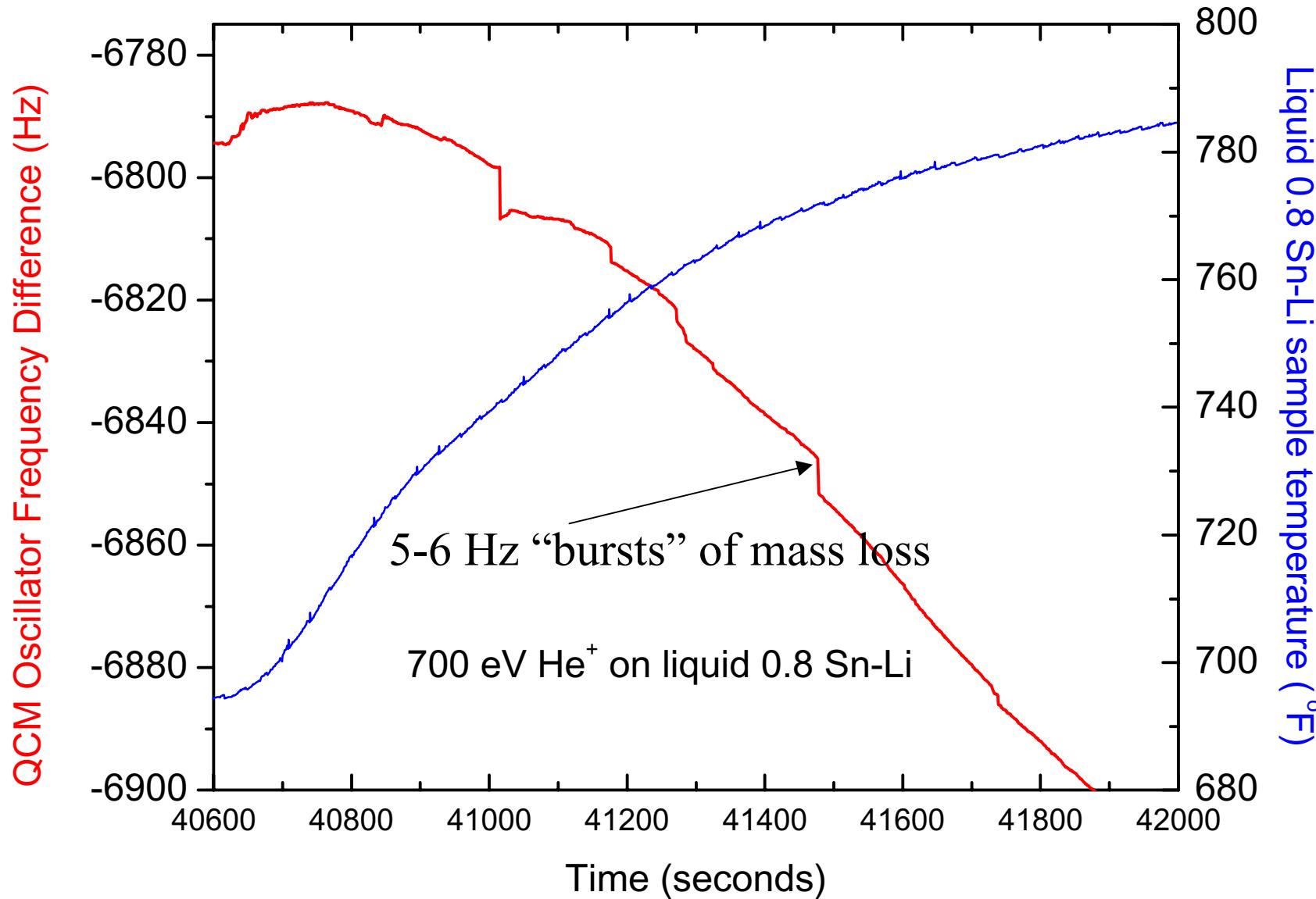
# Segregated lithium layer thickness as a function of liquid 0.8 Sn-Li temperature



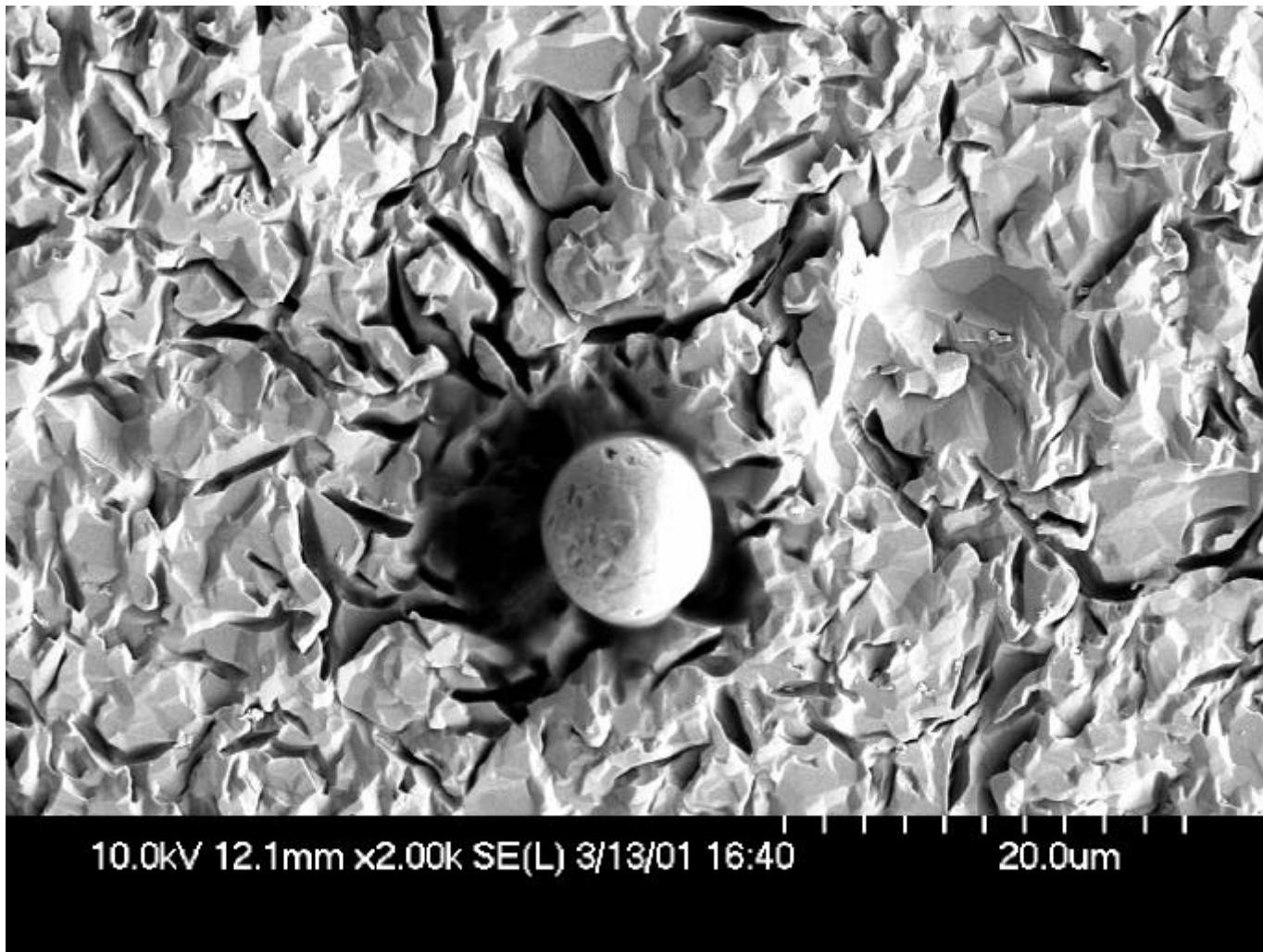
# Partial sputtering yields of lithium and tin from He bombardment as a function of segregated lithium layer



# QCM Frequency dependence on Liquid 0.8 Sn-Li sample temperature

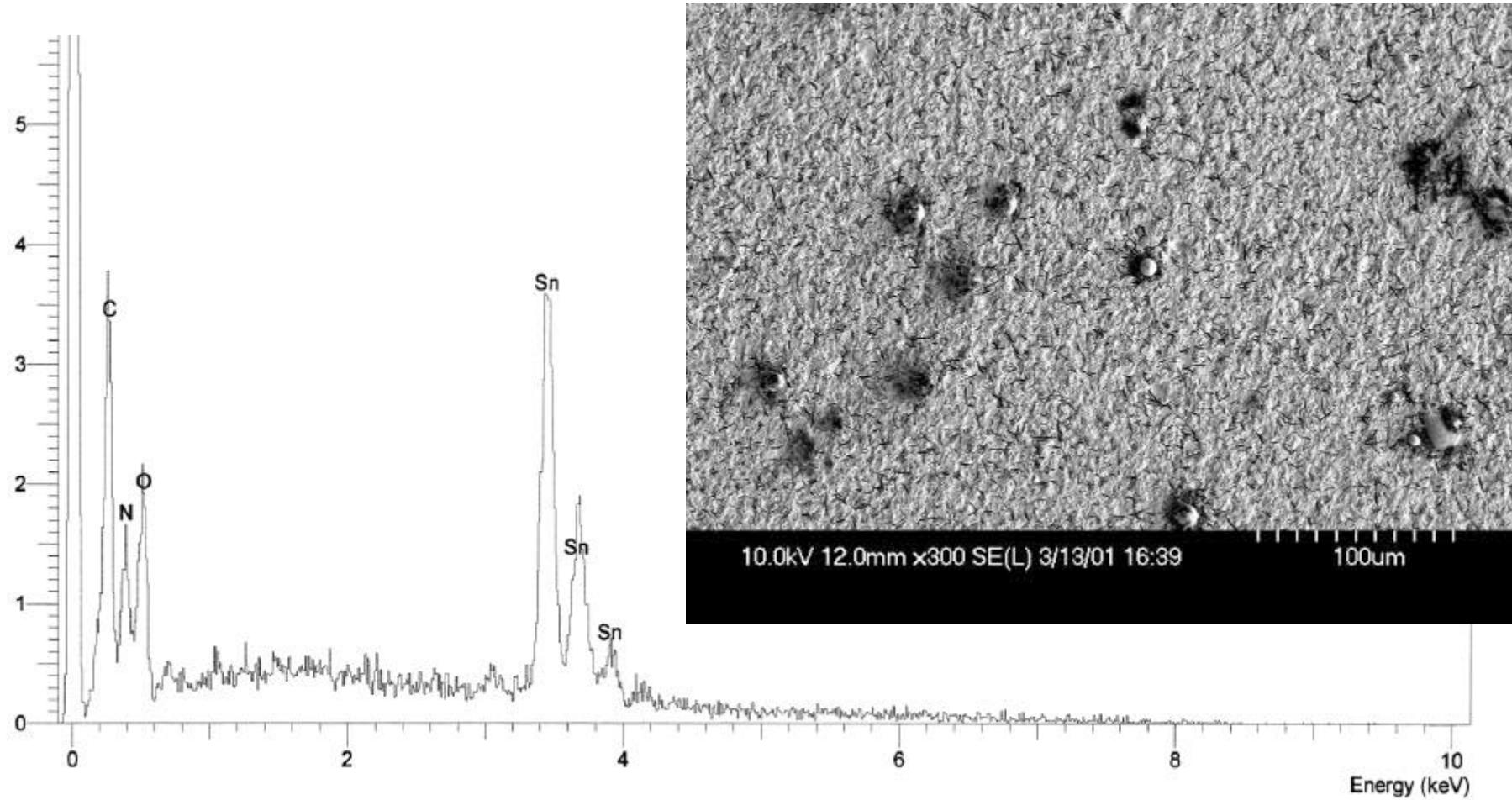


# SEM micrographs of macroscopic erosion in IIAX



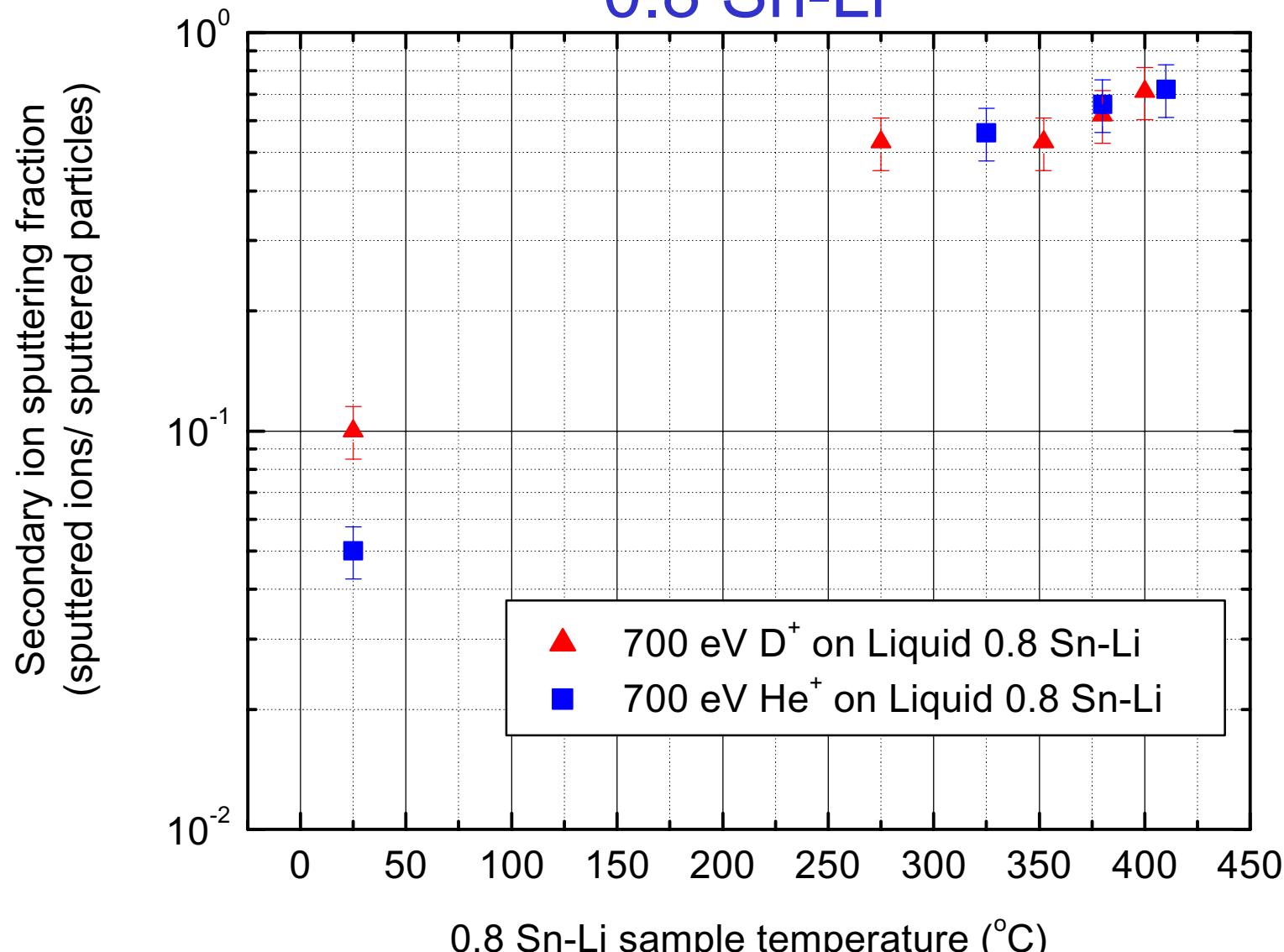
Large particulate  $\sim 6\text{-}7 \mu\text{m}$  is shown with crater

EDS (X-ray energy dispersive spectroscopy) confirmed that particulates are made of tin



Need to run XPS to determine amount of lithium in particulates

# Secondary ion sputtering fraction ( $Y_{sp}^+$ ) dependence on target temperature for Liquid 0.8 Sn-Li



# Liquid lithium and tin-lithium dependence on temperature at low incident flux

- Low flux ( $\sim 10^{14}$  ion/cm<sup>2</sup>/sec) not expected to result in dramatic enhanced erosion for temperatures near  $T/T_m \sim 1.0$ .  
**(P. Sigmund and M. Szymonski, Appl. Phys. A 33 (1984) 141-152)**
- Erosion enhancement is a result of combined mechanisms: local enhanced evaporation (net decrease in ejected sputtered energy), segregation, diffusion and possible bubble formation
- Key: liquid surface stratification...strong temperature dependence?
- Other key: understand transition from microscopic to macroscopic erosion (static vs dynamic liquid metal surfaces)
- Finally: Identify conditioning techniques that can address enhanced erosion, i.e. can  $Y_{sp}^+$  increase, surface treatment (deuterium, etc...)

# Important mechanisms to consider in liquid metal sputtering (not exclusive)

## Surface Stratification

S.A. Rice, P. Pershan, W.P. Morgan

## Bubble formation in liquid metals

L.B. Begrambekov, A. Hassanein

## Thermal Sputtering: local enhanced liquid-metal evaporation

R. Kelly, M.W. Nelson, R.S. Nelson, P. Sigmund

## Damage Distribution Theory: Gibbsian segregation, Radiation-enhanced diffusion, preferential sputtering

P. Sigmund, N. Lam, R. Kelly, A.R. Krauss, D.M. Gruen, J. Bohdansky, W. Eckstein, etc

Self-consistent model which addresses most of these mechanisms  
HEIGHTS, A. Hassanein (Argonne National Laboratory)

# Temporal and spatial scales relevant to liquid-metal sputtering

- Temporal Scales
  - Diffusion, segregation processes
  - Local temperature rise of impacted lattice region
  - Preferential sputtering
  - Desorption and recombination rates
  - Thermal spike and bubble formation
- Spatial Scales
  - Depth of origin of sputtered atoms
  - Depletion surface region
  - Range of ions
  - Thermal spike radius
  - Stratified layer thickness
  - Short-range order of liquid metal

# FLIRE (Flowing Liquid Surface Illinois Retention Experiment)

- FLIRE will provide fundamental data on the retention and pumping of He, H, and other gases in flowing liquid surfaces.

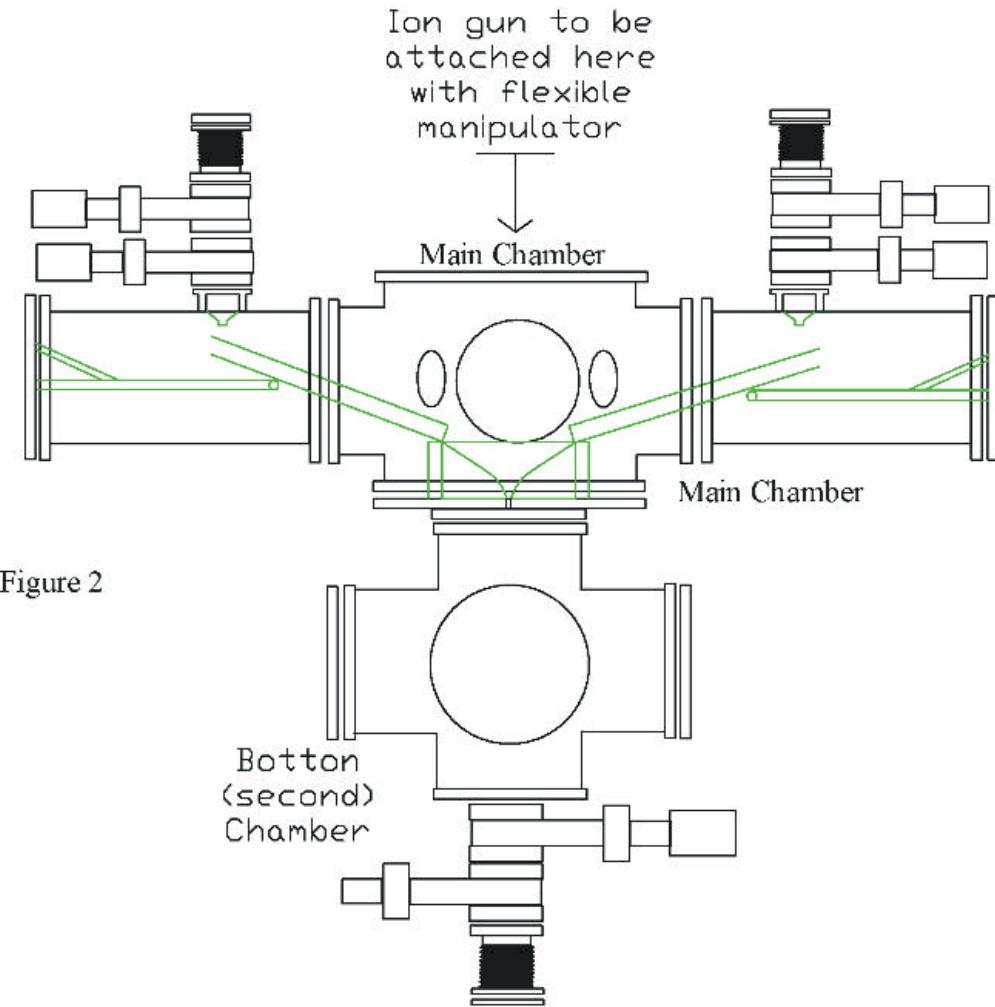
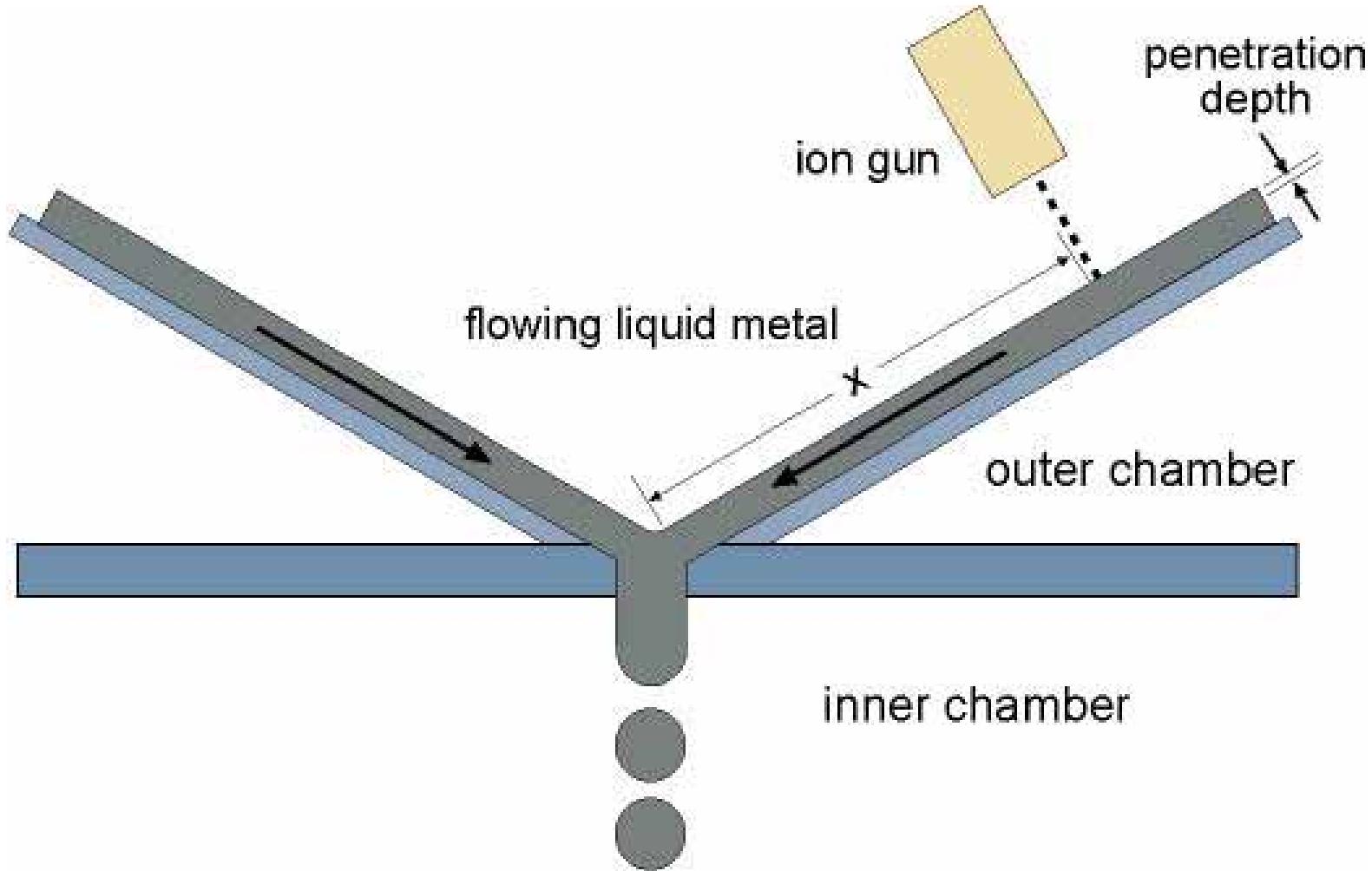


Figure 2

# FLIRE concept



# Conclusions

- Solid and liquid lithium sputtering yields measured in IIAX-UIUC show less-than unity self-sputtering yields.
- Measurements of liquid eutectic tin-lithium sputtering yields are larger than both measured solid and liquid pure lithium sputtering yields in IIAX.
- Ion fraction of sputtered species for liquid lithium and liquid tin-lithium are 55%-65% compared to <10% for solid phase tin-lithium.
- Deuteriation of lithium surface results in a ~ 60% decrease in absolute sputtering yield of lithium.

# Conclusions (cont.)

- Bombardment of liquid lithium and liquid tin-lithium show dramatic increase in absolute sputtering yield as temperature is increased.
- Sputtered ion fraction shows modest increase with sample temperature
- New models need to account for surface stratification and its effect on physical sputtering of candidate liquid metals

# Future Work Plan

- Experiments to understand temperature dependence of physical sputtering yield
  - Saturation and pre-treatment effects
  - Understand: desorption, segregation and diffusion mechanisms
  - Thermal spikes
  - Search for bubble burst events
- Ion-induced secondary electron yields
- Study other candidate materials (i.e. Sn)

# Acknowledgements

- DOE ALPS Program (Advanced Limiter/ Divertor Plasma-facing Surfaces)
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